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APPLICATION N	iO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/835,820	_	04/17/2001	Tomohisa Hoshino	P 280192 EL00028CDC	5539	
909	7590	07/27/2004		EXAM	EXAMINER	
		INTHROP, LLP	LUU, CH	LUU, CHUONG A		
P.O. BOX 10500 MCLEAN, VA 22102				ART UNIT	PAPER NUMBER	
				2825		
			DATE MAILED: 07/27/200	DATE MAILED: 07/27/2004		

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)				
		09/835,820	HOSHINO ET AL.				
	Office Action Summary	Examiner	Art Unit				
	_	Chuong A Luu	2825				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply							
THE I - Exter after - If the - If NO - Failur Any r	ORTENED STATUTORY PERIOD FOR REPL MAILING DATE OF THIS COMMUNICATION. sions of time may be available under the provisions of 37 CFR 1. SIX (6) MONTHS from the mailing date of this communication. period for reply specified above is less than thirty (30) days, a represent of the reply is specified above, the maximum statutory period reto reply within the set or extended period for reply will, by statutely received by the Office later than three months after the mailing patent term adjustment. See 37 CFR 1.704(b).	136(a). In no event, however, may a reply be tiled to be statutory minimum of thirty (30) da will apply and will expire SIX (6) MONTHS from the, cause the application to become ABANDONE.	mely filed ys will be considered timely. n the mailing date of this communication. ED (35 U.S.C. § 133).				
Status							
1)⊠	Responsive to communication(s) filed on 11 M	<i>May</i> 2004.					
2a) <u></u> ☐	This action is <b>FINAL</b> . 2b)⊠ Thi	s action is non-final.					
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Dispositi	on of Claims						
4)⊠ 5)□ 6)⊠ 7)□	Claim(s) 1-9 and 11-17 is/are pending in the application.  4a) Of the above claim(s) is/are withdrawn from consideration.  Claim(s) is/are allowed.  Claim(s) 1-9 and 11-17 is/are rejected.						
Applicati	on Papers						
	The specification is objected to by the Examiner.						
	The drawing(s) filed on is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.						
	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).  Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).						
_	The oath or declaration is objected to by the E		•				
Priority u	nder 35 U.S.C. § 119						
<ul> <li>12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).</li> <li>a) All b) Some * c) None of:</li> <li>1. Certified copies of the priority documents have been received.</li> <li>2. Certified copies of the priority documents have been received in Application No</li> <li>3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).</li> <li>* See the attached detailed Office action for a list of the certified copies not received.</li> </ul>							
<b>A44</b> aabuu 4	(5)						
Attachment 1) 🕅 Notice	(s) e of References Cited (PTO-892)	4) Interview Summary	/ (PTO-413)				
2)  Notice 3)  Inform	e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449 or PTO/SB/08 No(s)/Mail Date	Paper No(s)/Mail D					

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#### **DETAILED ACTION**

## Response to Arguments

Applicant's arguments with respect to claims 1-9 and 11-17 have been considered but are moot in view of the new ground(s) of rejection.

#### PRIOR ART REJECTIONS

# **Statutory Basis**

## Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

#### The Rejections

Claims 1-9 and 11-17 are rejected under 35 U.S.C. 102(e) as being anticipated by Subrahmanyan et al. (U.S. 6,693,030 B1).

Subrahmanyan discloses a precleaning process with

Respect to claims:

(1); (8); (14) forming a barrier layer on an insulating film covering a substrate; exposing the barrier layer to a first gas atmosphere containing a reducing gas and free of plasma at an elevated substrate temperature;

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forming, after said exposing said barrier conductor layer to said first gas atmosphere, a metal film on the barrier conductor layer by a CVD process;

exposing said metal film to a second gas atmosphere at an elevated substrate temperature (see column 11, lines 13-30);

- (2) wherein said first reducing gas atmosphere is selected from any of the group consisting of hydrogen (see column 11, lines 24-26);
- (4) wherein said second gas atmosphere includes hydrogen (see column 11, lines 28-30);
- (7) wherein said barrier conductor layer is formed of any of Ta or TaN (see column 11, lines 13-20);
  - (9) wherein said reducing gas is hydrogen (see column 11, lines 24-26);
- (11) further comprising, after said step of forming said metal film, a thermal annealing process applied to said metal film (see column 11, lines 13-30);
  - (6); (13) wherein said metal film is formed of Cu (see column 11, lines 25-30);
- (15) wherein said step of forming said barrier conductor layer is conducted by a PVD process (see column 11, lines 15-20);
- (16) wherein said second gas atmosphere includes nitrogen (see column 11, lines 13-30)
- (17) wherein said step of exposing said metal film to said second gas atmosphere is conducted under a pressure of about 40 Pa (see column 9, lines 66-67).

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#### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Chuong A Luu whose telephone number is (571) 272-1902. The examiner can normally be reached on M-F (6:30-3:00).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Matthew Smith can be reached on (571) 272-1907. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

CAL March 2, 2004

CARIDAD EVERHART PRIMARY EXAMINER